

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	METHOD AND SYSTEM FOR DYNAMIC MODELING AND RECIPE OPTIMIZATION OF SEMICONDUCTOR ETCH PROCESSES										
Application Number : 10/523777											
Confirmation Number: 5732											
First Named Applicant: Kun Li											
Attorney Docket Number: VOY007US											
Art Unit: 2825											
Examiner:											
Search string: (6133132).pn											
US Patent Documents											
Note: Applicant is not required to submit a paper copy of cited US Patent Documents											
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass				
SRG	1	6133132	2000-10-17	Toprac et al.							
Signature											
<table border="1"><tr><td>Examiner Name</td><td>Date</td></tr><tr><td>/Steven Garland/</td><td>08/09/2006</td></tr></table>				Examiner Name	Date	/Steven Garland/	08/09/2006				
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